



IFW

PATENT  
8040-1059

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Wataru HATTORI

Conf. 2934

Application No. 10/501,762

Group 2812

Filed July 19, 2004

Examiner Savitri Mulpuri

METHOD OF MANUFACTURING SURFACE  
ACOUSTIC WAVE DEVICE AND  
SEMICONDUCTOR DEVICE

**RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 23, 2005

Sir:

This responds to the Official Action of May 27, 2005.

**Remarks** begin on page 2 of this paper.

An **Appendix** is attached which follows the signature  
page of this paper.

Make of record the accompanying verified translation of  
Japanese priority application No. 2002-8501, filed January 17,  
2002.